Microstructure and growth mechanism of stressed complex oxide thin films in strain-modulation

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A series of experiments of strain modulations in heterostructures of SrTiO₃/LaAlO₃ and LaAlO₃/SrTiO₃ perovskite thin films fabricated by laser molecular beam epitaxy (L-MBE) were performed to study the effect of the compressive stress and tensile stress on the growth and microstructure of the films. The growth process of the films was in-situ monitored by reflective high-energy electron diffraction (RHEED). The morphology of the films was studied by ex-situ atomic force microscopy (AFM). We demonstrated that the compressive stress-induced self-organized SrTiO₃ films deposited on LaAlO₃ (100) single crystal substrates exhibited a periodic well-ordered ripple-shaped structure, forming a unique nanopatterning tool to fabricate 1D/2D arrays of confined nanostructures (i.e., islands and wires). Small angle X-ray scattering technique was employed to investigate the superstructure. Symmetric satellite peaks were observed, which also revealed the well-aligned self-organized structures. In contrast, the similar superstructure was not observed during the growth of the tensile stress-induced LaAlO3 films on SrTiO₃ substrates. Based on the experimental data, the compressive stress was estimated as the main reason of the self-organized growth. A growth model about the formation mechanisms of compressive stress-induced nanostructure was put forward and systematical kinetics elucidations about the growth processes were also discussed to illustrate the effects of different stresses on the growth and microstructures of the films. © 2006 Springer Science + Business Media, Inc.

1. Introduction

Motivated by the novel properties and their increasing technological interest (note for instance, the crucial advances in high-*Tc* superconductors, ferroelectrics and colossal magnetoresistors) based on the confinement effect, more extensive technological and scientific attention was paid to a new emerging oxide-based nanotechnology [1–4]. Through controlled strain engineering, the fabrication by strain-induced self-organizing routes of ordered arrays of spatially-confined inorganic nanostructures constitutes currently one of the frontier subjects in the field of the nanotechnology [2–5]. However, the physical mechanisms and that drive self-organized growth have been studied in details only for semiconductors, but not

systematically for complex oxides thin film. Perovskite SrTiO₃ thin films have been intensively investigated for their applications to ultrathin gate oxide [6–8] and electrically tunable microwave devices [9, 10]. Recently, with the strain-modulation in the SrTiO₃ film, which is not normally ferroelectric at any temperature, the ferroelectric transition temperature (*Tc*) were increased by hundreds of degrees, and the room-temperature ferroelectricity was obtained, which are detrimental to tunability and microwave devices performance [1]. Obviously, strain in the ferroelectric films plays a significant role in influencing their microstructures, as well as the dielectric properties, which are important for electronic applications. The influences of stresses to the films growth and their

microstructures are complex, and a clear understanding of the nature of stresses is of both scientific and technological significance. Some studies about the effect of the temperature on the lattice constants and strain relaxation process during the growth of the film at the growing temperature were made [11–13]. However, systematic studies about different influence of the compressive stress and tensile stress on the films structure and the growth are so far lacking.

In this letter, we fabricated the SrTiO₃/LaAlO₃ and LaAlO₃/SrTiO₃ heterostructures, respectively, via proper modulation of strains to study the effects of the compressive stress and tensile stress on the films growth and their microstructures. By the compressive stress-induced self-organization of SrTiO₃ films, the well-aligned periodic nanostructures were fabricated. A growth dynamic model and systematical illustrations were put forward to express the effects of different stresses on the films for better comprehension of the strain mechanism in the heterostructures.

2. Experiment

The heteroepitaxial SrTiO₃ and LaAlO₃ films were fabricated on LaAlO₃ (100) and SrTiO₃ (100) single crystal substrates, respectively, with laser molecular beam epitaxy (LMBE) using KrF ($\lambda = 248$ nm) excimer laser (LAMBDA PHYSIK, 2 J/cm² and 3 Hz). The depositions were made in high vacuum chamber (base vacuum pressure: 1×10^{-5} Pa) at 650° C substrate temperature. The reflective high-energy electron diffraction (RHEED) system was used for *in-situ* monitoring the film growth. The morphology of the films was characterized by atomic force microscopy (AFM, SPA-300 HV, SEIKO). Small angle X-ray scattering (SAXS) technique was carried out to investigate the surface structure of SrTiO₃ films grown on LaAlO₃ substrate. The θ -2 θ scan and ω scan at a small angle were performed in a X'Pert Philips diffractometer using Cu K α radiation.

SrTiO₃ (100) and LaAlO₃ (100) single crystal substrates with small miscut angles (0.2°) were selected for this experiment to exclude step-flow like growth behavior to obtain highly atomic smooth surface, which were confirmed by AFM images in our previous work [14]. Before deposition, the substrates were in-situ annealed at the temperature of 800°C to get a carbon-free and high-crystalline surface without other special morphology [3, 14]. Since the room-temperature lattice constant of SrTiO₃ and LaAlO₃ are 0.3905 nm and 0.379 nm, respectively, one expects the mismatch stress in the SrTiO₃ films to be compressive on LaAlO₃, while in the LaAlO₃ films to be tensile on SrTiO₃.

3. Results and discussion

The RHEED patterns and intensity oscillations obtained during the SrTiO₃ film growth on LaAlO₃ (100) substrate were showed in Fig. 1. In the initial growth stage of the film, the bright streaky RHEED patterns shown in the

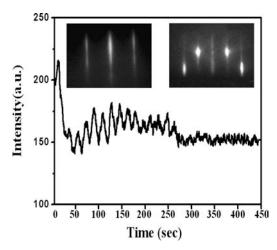


Figure 1 RHEED intensity oscillations and patterns of SrTiO₃ thin films grown on LaAlO₃ (100) substrate (in the left inset: the initial streaky RHEED patterns in 2D layer-by-layer growth mode, in the right inset: the later spotty plus streaky RHEED patterns in 3D island growth mode, below: the corresponding RHEED intensity oscillations).

left inset and the corresponding undamped intensity oscillation of the SrTiO₃ film were observed. The RHEED patterns had clear bright 1 × 1 streaks, indicating that the films had an atomic flatness and single-phase perovskite structure. One period of oscillation corresponded to the growth of one unit cell of SrTiO₃, which meant that the film growth proceeded in the 2 dimensions (2D) layer-by-layer fashion. With film thickness increasing, the amplitude of the oscillations decreased, no significant recovery behavior was achieved and the spotty plus streaky RHEED patterns appeared, which was shown in the right inset. This indicated a transition from initial 2D layer-by-layer growth mode to 3 dimensions (3D) growth fashion after a few monolayers [14].

Fig. 2 showed the morphologic evolution of the SrTiO₃ films obtained from different growth stage. The SrTiO₃ film grown on flat LaAlO₃ substrate [Fig. 2a] with 3.9 nm thickness (about 10 unit cells) [Fig. 2b] showed a periodic ripple structure, which was a result of the relief of stress due to the 3.0% lattice mismatch exiting between the film and the substrate. Since the lattice parameter of SrTiO₃ is larger than that of LaAlO₃, the stress in the epitaxial SrTiO₃ film is compressive. With the film thickness increasing, the film releases stress by creating additional surface roughness.

The ripple structure produced a nonuniform distribution of stress at the surface, where a well-ordered nucleation arrangement was obtained, as shown in Fig. 2b. The interripple regions remained stressed and unfavorable to nucleation, while the peaks of ripple were stress-relaxed, resulting in the formation of nucleation center. As the film thickness increased, mismatch dislocation could be formed, leading to strain relaxation. The dislocation position at the surface could act as the nucleation center. Thus, 3D irregular islands were developed from these nucleation centers with the film thickness of 10.33 nm, as shown in

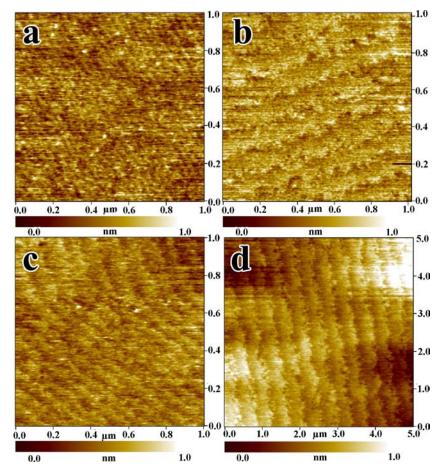


Figure 2 Evolution of the surface morphology AFM images of the self-assembled SrTiO₃ films on LaAlO₃ with the growth time and the film thickness: (a) (0 nm), (b) (3.9 nm), (c) (10.33 nm), (d) (46.50 nm). The area scanned by AFM was $1 \text{ mm} \times 1 \text{ mm}^2$ in a, b, c and $5 \text{ mm} \times 5 \text{ mm}^2$ in d.

Fig. 2c, which was also in agreement with the RHEED patterns and intensity oscillations obtained at the corresponding stage during the growth, suggesting that the growth proceeded in 3D island growth mode. It was interesting that a well-aligned ripple structure appeared again during the further growth of the film. The inplane lattice of SrTiO₃ had been compressed due to compressive stress. As the 3D growth of the film, the strain had been partially relaxed. When the islands were aligned in more regular continuous form and became nanopattern with a uniform size, the ripple structure occurred again under relatively less compressive stress. Therefore, the distance between the ripples become larger, and streak of ripple was also bigger. Then, the periodic well-ordered ripple-shaped nanostructures were formed as shown in Fig. 2d.

Based on these results, the effects of the compressive stress between the SrTiO₃ film and the LaAlO₃ substrate should be responsible for the well-aligned self-organized growth of the SrTiO₃ films.

In order to investigate the effects of tensile stress on films growth, the LaAlO₃ thin films were fabricated on SrTiO₃ (100) substrates under the same deposition conditions with the same deposition technique, which were mentioned above in this letter. The LaAlO₃ film was

drew by tensile stress resulting from the lattice mismatch between LaAlO₃ film and SrTiO₃ substrate. During the growth process, the RHEED and AFM were also employed. The clear bright streaky RHEED patterns of the LaAlO₃ films and undamped intensity oscillations were obtained during the overall deposition, as shown in Fig. 3a, suggesting that the films had an atomic smooth surface. This demonstrated that the film grew in layer-by-layer mode. Fig. 3b also showed the AFM image of LaAlO₃ films, which had an atomic flatness with 0.2137 nm RMS. However, ripple structure didn't appear. It was suggested that tensile stress could not result in the formation of a ripple-shaped nanostructure. Tensile stress can enlarge the in-plane lattice of LaAlO₃. Consequently, the area of growth surface became larger. The energy of tensile stress can be released by the enhanced surface energy. Thus, the ripple structure did not appear.

In order to further investigate the self-organized structure in the obtained film, SAXS technology was carried out to characterize the nanostructure of SrTiO₃/LaAlO₃. θ –2 θ scan curve of self-patterned SrTiO₃ film on LaAlO₃ (100) substrate was shown in Fig. 4a. According to the fluctuation in the curve, the thickness of SrTiO₃ film can easily be calculated to be 46.5 nm. Unlike the usual single layer film, there was a peak at the position (2 θ = 0.8°).

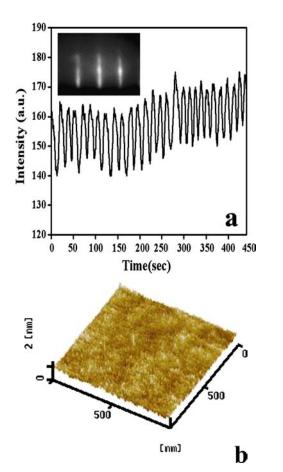


Figure 3 (a) RHEED patterns, intensity oscillations, and (b) AFM images of LaAlO₃ thin films on SrTiO₃ (100) substrates.

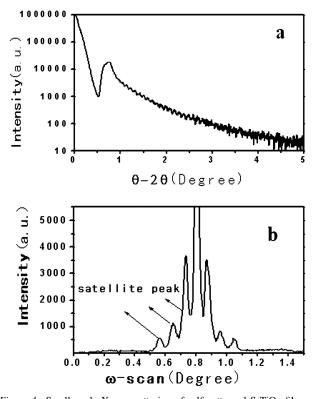


Figure 4 Small angle X-ray scattering of self-patterned SrTiO₃ film on LaAlO₃ (100): θ –2 θ scan curve (a), ω scan curve (b).

It could be concluded that the appearance of the peak at small angle indicated the in-plane self-patterned structure.

The ω scan curve of the self-patterned SrTiO₃/LaAlO₃ (100) was shown in Fig. 4b. Symmetric satellite peaks can be clearly observed around the main peak, which demonstrated that the self-organized film had a special periodic structure, since the satellite peaks observed in the rocking scan curve closely demonstrate the well-ordered periodic structure along the out-plane direction. The SAXS results were quite in agreement with our above AFM observations. When the same SAXS method was also employed to characterize the LaAlO₃/SrTiO₃ (100) substrate, however, similar phenomena were not observed. SAXS experiments also confirmed that the compressive stress was the main reason to form the well-ordered ripple nanostructure of SrTiO₃/LaAlO₃.

Based on the above-mentioned experimental data, the systematical kinetics process of the self-organization caused by compressive stress was suggested. A model about the formation mechanisms of this nanostructure originating from the strain could be put forward.

In the case of SrTiO₃/LaAlO₃, SrTiO₃ film grow coherently epitaxially on the LaAlO₃ substrate in 2D layerby-layer mode, since the SrTiO₃ film was very thin with only a few monolayers, as shown in Fig. 5a [4]. This process was confirmed by the RHEED patterns and intensity oscillations shown in Fig. 1. The compressive stress at this stage was not readily relaxed due to the extremely small film thickness. The film was constrained due to the small difference of lattice parameter between LaAlO₃ and SrTiO₃. With further growth, the compressive stress could be relaxed by the formation of misfit dislocations in the film, as shown in Fig. 5b. After the formation of misfit dislocation the distributions of stress at the interface was nonuniform. The areas where misfit dislocation located underneath were stressed, where those regions between neighboring misfit dislocations were unconstrained or less constrained. Adatoms on the film surface will form the stress regions to the unstressed regions through a surface diffusion process. With further growth, the compressive stress assembled, while the strain energy decreased with the increasing of the surface energy to achieve the equilibrium state of energy. As a result, a self-nanoassembled rippled structure was formed, as shown in Fig. 5c, which was in agreement with the RHEED oscillations and the observed surface morphology changes, which were shown in Figs. 1 and 2d. The formation of the rippled structure could decrease the strain energy in the film and the system could achieve the minimum of free energy to get the stable energy state. As a result, well-ordered self-organized SrTiO₃ film grown on LaAlO₃ substrate was fabricated. In the heterostructures of LaAlO₃/SrTiO₃, however, during the initial deposition the LaAlO₃ film grew coherently epitaxially on the SrTiO₃ substrate with 2D layer-by-layer fashion with the thickness thinned as only a few monolayers, which was shown in Fig. 6a. With the LaAlO₃ film growth proceeding the film was drew in-plane by tensile stress and there were no strained or unstrained

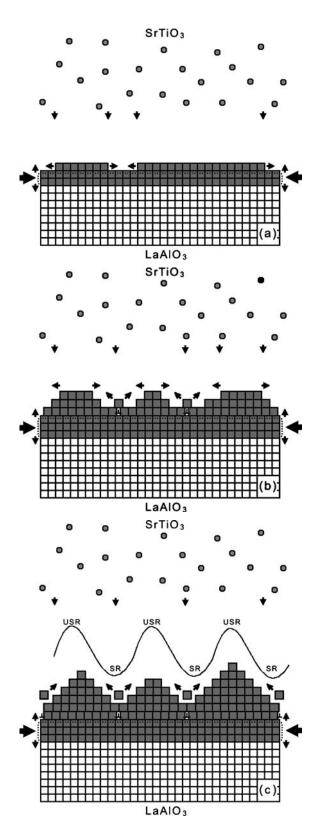


Figure 5 Schematics showing the growth mechanisms of SrTiO₃ thin films on the LaAlO₃ (100) substrate. (a) SrTiO₃ grew in 2D growth mode when the thickness thinned with only a few monolayers; (b) and misfit dislocations formed when the film growth reaches a critical thickness; (c) Formation of ripple-shaped surface structure due to the assembled compressive stress with the stressed regions (SR) to unstressed regions (USR).

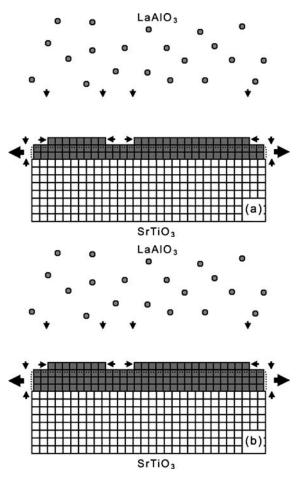


Figure 6 Schematics showing the growth mechanisms of LaAlO₃ thin films on the SrTiO₃ (100) substrate. (a) 2D growth fashion of LaAlO₃ films at the initial stage; (b) The tensile stress relaxed gradually with the increasing of the film thickness and could not take effect on the change of surface structure of the LaAlO₃ films.

regions on the surface of the LaAlO₃ films, which was different from the compressed SrTiO₃ films. The tensile stress, which relaxed gradually with the increasing the film thickness, could not take effect on the change of surface structure of the LaAlO₃ films. Thus, an atomically flat surface of LaAlO₃ film could be obtained, as shown in Fig. 6b, which are different from that of SrTiO₃ films under the otherwise same deposition conditions.

4. Conclusions

In conclusion, through controlled strain engineering, compressive stressed-induced self-organized SrTiO₃ films is fabricated on LaAlO₃, providing a nanopatterning tool to fabricate 1D/2D arrays of confined nanostructures (i.e., islands and wires). Many methods were employed to characterize the microstructures and growth processes of the films. In terms of strain-modulation, we illustrate the effects of different stresses on the films growth and their microstructures.

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